35.G2387



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Examiner: Unassigned

HIDEHIKO FUJIMURA, ET AL.

Group Art Unit: Unassigned

Application No.: 09/309,766

Filed: May 11, 1999

November 2, 1999

METHOD FOR MANUFACTURING)

AIRTIGHT VESSEL AND

IMAGE-FORMING APPARATUS USING AIRTIGHT VESSEL

RECEIVED

The Assistant Commissioner for Patents

20231 Washington, D.C.

NOV 0 - 1999 Group 3700

INFORMATION DISCLOSURE STATEMENT

Sir:

DC_MAIN 5662 v 1

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under N 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanations of relevance for the non-English documents are provided in the Description of Related Art section of the specification.

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CONCLUSION

TECHNOLOGY CENTER 280

It is respectfully requested that the above information be considered by the Examiner and that an

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initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010.

All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. 32,533

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3801 Facsimile: (212) 218-2200

SDM\rnm

FORM PTO 1449 (modified)				ATTY DOCKET NO / 35. G2387	APPLICATION NO. 09/309,766		15	
U.S. DEPARTMENT OF COMMERCE P PATENT AND TRADEMARK OFFICE P LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) (Use several sheets if necessary)								
(Use several sheets if necessary) Submitted to the PTO: November 2, 1999 NOV 0 2 1999						GROUP Unassigne	ROUP Jnassigned	
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL	DOCUMENT NUMBER DATE			NAME	CLAS	TECH S BUBCLASS	FILING DATE	
	5,925,979	07/1999		Azuma, et al.	313	106 106	REC	
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				RS	Ser Can	2000 NTL-R-371	<u>ED</u>	
			NUV			U+ 1 3 0		
	FOREIGN PATENT DOCUMENTS G70110 3700							
	DOCUMENT NUMBER	DATE	, ,, 	COUNTRY	CLAS	S SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT	
	7-302545	11/1995		Japan			Abstract	
,	7-296748	11/1995		Japan		1:0	Abstract	
	7-296731	11/1995		Japan		CINCL	-Abstract	
						AR -2	AIBO.	
						₩ 2	K	
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)								
W.P. Dyke, et al., "Field Emission", Advances in Electronics and Electron Physics, pp. 90-185 (1956).								
	C.A. Spindt, et al., "Physical Properties of Thin-Film Field Emission Cathodes with Molybdenum Cones", Journal of Applied Physics, Vol. 47, No. 12, pp. 5248-5263 (D c mb r 1976).							
	C.A. Mead, "Operation of Tunnel-Emission Devices", Journal of Applied Physics, Vol. 32, No. 4, pp. 646-652 (April 1961).							
	M.I. Elinson, et al., "The Emission of Hot Electrons and the Field Emission of Electrons From Tin Oxide", Radio Engineering and Electronic Physics, No. 7, pp. 1290-1296 (July 1965).							
	G. Dittmer, "Electrical Conduction and Electron Emission of Discontinuous Thin Films", Thin Solid Films, Vol. 9, pp. 317-328 (1972).							
	H. Araki, et al., "Electroforming and Electron Emission of Carbon Thin Films", Journal of Vacuum Society of Japan, Vol. 26, No. 1, pp. 22-29 (January 1983).							
	M. Hartwell, et al., "Strong Electron Emission From Patterned Tin-Indium Oxide Thin Films", International Electron Devic s M ting, pp. 519-521 (1975).							
EXAMINER								

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

NOV 2 2 1999

Sheet_1_ of _1_